

Form 1449*		Docket Number: P9492.00		Application Number:	
INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary)		Applicant: Martin T. Gerber and John M. Swoyer			
		Filing Date:		Group Art Unit:	
		Examiner Name:			
U.S. PATENT DOCUMENTS					
Examiner Initial	Document Number	Issue/Document Publication Date	Name		Filing Date If Appropriate
DDG	20030045919	03/06/2003	Swoyer et al.		
DDG	20020161423	10/31/2002	Lokhoff et al.		
DDG	6,360,750	03/26/2002	Gerber et al.		
FOREIGN PATENT DOCUMENTS					
Examiner Initial	Document Number	Publication Date	Country	Translation	
				Yes	No
OTHER DOCUMENTS (Including Authors, Title of Item, Page(s), Vol/Issue No., Publisher, Place of Publication)					
EXAMINER			Date Considered		
Dana D. Keene			4-14-05		
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